



1449-A and B (Modified)

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Sheet 1 of 17

APPLICATION NO.: 10/537,760

ATTY. DOCKET NO.: 2002P87059WOUS

FILING DATE: June 6, 2005

CONFIRMATION NO.: 5173

APPLICANT: Fufang Zha et al.

GROUP ART UNIT: 1797

EXAMINER: Menon, Krishnan S.

U.S. PATENT DOCUMENTS

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
		*256,008		Leak	04-04-1882
		*285,321		Tams	09-18-1883
		*1,997,074		Novotny	04-09-1935
		*2,080,783		Petersen	05-18-1937
		*2,105,700		Ramage	01-18-1938
		*2,843,038		Manspeaker	07-15-1958
		*2,926,086		Chenicek et al.	02-23-1960
		*3,183,191		Hach	05-11-1965
		*3,198,636		Bouthilet	08-03-1965
		*3,228,876		Mahon	1-11-1966
		*3,442,002		Geary et al.	05-06-1969
		*3,462,362		Kollsman	08-19-1969
		*3,492,698		Geary et al.	02-03-1970
		*3,556,305		Shorr	01-19-1971
		*3,591,010		Pall	07-06-1971
		*3,625,827		Wildi et al.	12-07-1971
		*3,654,147		Levin et al.	04-04-1972
		*3,693,406		Tobin, III	09-26-1972
		*3,700,561		Ziffer	10-24-1972
		*3,708,071		Crowley	01-02-1973
		*3,728,256		Cooper	04-17-1973
		*3,763,055		White et al.	10-02-1973
		*3,791,631		Meyer	02-12-1974
		*3,804,258		Okuniewski et al.	04-16-1974
		*3,843,809		Luck	10-22-1974
		*3,876,738		Marinaccio et al.	04-08-1975
		*3,955,998		Clampitt et al.	05-11-1976
		*3,968,192		Hoffman, III et al.	07-06-1976
		*3,992,301		Shippey et al.	11-16-1976
		*3,993,816		Baudet et al.	11-23-1976
		*4,049,765		Yamazaki	09-20-1973
		*4,076,656		White et al.	02-28-1978
		*4,082,683		Galesloot	04-04-1978
		*4,105,731		Yamazaki	08-08-1978
		*4,107,043		McKinney	08-15-1978
		*4,138,460		Tigner	02-06-1979
		*4,183,890		Bollinger	01-15-1980

FORM PTO-1449-A and B (Modified)			APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
			APPLICANT: Fufang Zha et al.	
Sheet	2	of	17	GROUPE ART UNIT: 1797
				EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
		*4,188,817		Steigelmann	02-19-1980
		*4,190,411		Fujimoto	02-26-1980
		*4,192,750		Elfes et al.	03-11-1980
		*4,193,780		Cotton, Jr. et al.	03-18-1980
		*4,203,848		Grandine, II	05-20-1980
		*4,204,961		Cusato, Jr.	05-27-1980
		*4,218,324		Hartmann et al.	8-19-1980
		*4,226,921		Tsang	10-07-1980
		*4,227,295		Bodnar et al.	10-14-1980
		*4,230,583		Chiolle et al.	10-28-1980
		*4,247,498		Castro	01-27-1981
		*4,248,648		Kopp	02-03-1981
		*4,253,936		Leysen et al.	03-03-1981
		*4,271,026		Chen et al.	06-02-1981
		*4,302,336		Kawaguchi et al.	11-24-1981
		*4,340,479		Pall	07-20-1982
		*4,350,592		Kronsbein	09-21-1982
		*4,353,802		Hara et al.	10-12-1982
		*4,359,359		Gerlach et al.	11-16-1982
		*4,369,605		Opersteny et al.	01-25-1983
		*4,384,474		Kowalski	05-24-1983
		*4,385,150		Miyake et al.	05-24-1983
		*4,388,189		Kawaguchi et al.	06-14-1983
		*4,389,363		Molthrop	06-21-1983
		*4,407,975		Yamaguchi	10-04-1983
		*4,414,113		LaTerra	11-08-1983
		*4,414,172		Leason	11-08-1983
		*4,431,545		Pall et al.	02-14-1984
		*4,451,369		Sekino et al.	05-29-1984
		*4,476,112		Aversano	10-09-1984
		*4,491,522		Ishida et al.	01-01-1985
		*4,496,470		Kapiloff et al.	01-29-1985
		*4,511,471		Müller	04-16-1985
		*4,519,909		Castro	05-28-1985
		*4,540,490		Shibata et al.	10-15-1985
		*4,547,289		Okano et al.	10-15-1985
		*4,609,465		Miller	09-02-1986
		*4,610,789		Barch	09-09-1986
		*4,614,109		Hofmann	09-30-1986

FORM PTO-1449-A and B (Modified)			APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
			APPLICANT: Fufang Zha et al.	
Sheet	3	of	17	GROUP ART UNIT: 1797
				EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
		*4,623,670		Mutoh et al.	11-18-1986
		*4,629,563		Wrasidlo	12-16-1986
		*4,632,745		Giuffrida et al.	12-30-1986
		*4,636,296		Kunz	01-13-1987
		*4,642,182		Drori	02-10-1987
		*4,647,377		Miura	03-03-1987
		*4,650,586		Ellis, III	03-17-1987
		*4,650,596		Schleuter et al.	03-17-1987
		*4,656,865		Callan	04-14-1987
		*4,660,411		Reid	04-28-1987
		*4,666,543		Kawano	05-19-1987
		*4,670,145		Edwards	06-02-1987
		*4,673,507		Brown	06-16-1987
		*4,687,561		Kunz	08-18-1987
		*4,687,578		Stookey	08-18-1987
		*4,688,511		Gerlach et al.	08-25-1987
		*4,689,191		Beck et al.	08-25-1987
		*4,702,836		Mutoh et al.	10-27-1987
		*4,702,840		Degen et al.	10-27-1987
		*4,707,266		Degen, et al.	11-17-1987
		*4,708,799		Gerlach et al.	11-24-1987
		*4,718,270		Storr	01-12-1988
		*4,744,240		Reichelt	05-17-1988
		*4,749,487		Lefebvre	06-07-1998
		*4,756,875		Tajima et al.	07-12-1988
		*4,763,612		Iwanami	08-16-1988
		*4,767,539		Ford	08-30-1988
		*4,774,132		Joffee et al.	09-27-1988
		*4,775,471		Nagai et al.	10-04-1988
		*4,779,448		Gogins	10-25-1988
		*4,781,831		Goldsmith	11-01-1988
		*4,784,771		Wathen et al.	11-15-1988
		*4,793,932		Ford et al.	12-27-1988
		*4,797,187		Davis et al.	01-10-1989
		*4,797,211		Ehrfeld et al.	01-10-1989
		*4,810,384		Fabre	03-07-1989
		*4,812,235		Seleman et al.	03-14-1989
		*4,816,160		Ford et al.	03-28-1989
		*4,824,563		Iwahori et al.	04-25-1989

FORM PTO-1449-A and B (Modified)			APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
			APPLICANT: Fufang Zha et al.	
Sheet	4	of	17	GROUP ART UNIT: 1797
				EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
		*4,834,998		Shrikhande	05-30-1989
		*4,839,048		Reed et al.	06-13-1989
		*4,840,227		Schmidt	06-20-1989
		*4,846,970		Bertelsen et al.	07-11-1989
		*4,867,883		Daigger et al.	09-19-1989
		*4,876,006		Ohkubo et al.	10-24-1989
		*4,876,012		Kopp et al.	10-24-1989
		*4,886,601		Iwatsuka et al.	12-12-1989
		*4,888,115		Marinaccio et al.	12-19-1989
		*4,904,426		Lundgard et al.	02-27-1990
		*4,919,815		Copa et al.	04-24-1990
		*4,921,610		Ford et al.	05-01-1990
		*4,931,186		Ford et al.	06-05-1990
		*4,933,084		Bandel et al.	06-12-1990
		*4,935,143		Kopp et al.	06-19-1990
		*4,963,304		Im et al.	10-16-1990
		*4,968,430		Hildenbrand et al.	11-06-1990
		*4,968,733		Muller et al.	11-06-1990
		*4,969,997		Klüver et al.	11-13-1990
		*4,988,444		Applegate et al.	01-29-1991
		*4,999,038		Lundberg	03-12-1991
		*5,005,430		Kibler et al.	04-09-1991
		*5,015,275		Beck et al.	05-14-1991
		*5,024,762		Ford et al.	06-18-1991
		*5,034,125		Karbachs et al.	07-23-1991
		*5,043,113		Kafchinski et al.	08-27-1991
		*5,059,317		Marius et al.	10-22-1991
		*5,066,375		Parsi et al.	11-19-1991
		*5,066,401		Müller et al.	11-19-1991
		*5,066,402		Anselme et al.	11-19-1991
		*5,069,065		Sprunt et al.	12-3-1991
		*5,075,065		Effenberger et al.	12-24-1991
		*5,076,925		Roesink et al.	12-31-1991
		*5,079,272		Allegrezza et al.	01-07-1992
		*5,094,750		Kopp et al.	03-10-1992
		*5,094,867		Detering et al.	03-10-1992
		*5,098,567		Nishiguchi	03-24-1992
		*5,104,535		Cote et al.	04-14-1992
		*5,104,546		Filson et al.	04-14-1992

FORM PTO-1449-A and B (Modified)			APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
			APPLICANT: Fufang Zha et al.	
Sheet	5	of	17	GROUP ART UNIT: 1797
				EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
		*5,135,663		Newberth, III et al.	08-04-1992
		*5,137,631		Eckman et al.	08-11-1992
		*5,138,870		Lyssy	08-18-1992
		*5,147,553		Waite	09-15-1992
		*5,151,191		Sunaoka, et al.	09-29-1992
		*5,151,193		Grobe et al.	09-29-1992
		*5,158,721		Allegrezza, Jr. et al.	10-27-1992
		*5,169,528		Karbachsch et al.	12-08-1992
		*5,182,019		Cote et al.	01-26-1993
		*5,192,442		Piccirillo et al.	03-09-1993
		*5,192,456		Ishida et al.	03-09-1993
		*5,192,478		Caskey	03-09-1993
		*5,194,149		Selbie et al.	03-16-1993
		*5,198,116		Comstock et al.	03-30-1993
		*5,198,162		Park et al.	03-30-1993
		*5,209,852		Sunaoka et al.	05-11-1993
		*5,211,823		Giuffrida et al.	05-18-1993
		*5,221,478		Dhingra et al.	06-22-1993
		*5,227,063		Langerak et al.	07-13-1993
		*5,248,424		Cote et al.	09-28-1993
		*5,262,054		Wheeler	11-16-1993
		*5,271,830		Faivre et al.	12-21-1993
		*5,275,766		Gadkaree et al.	01-4-1994
		*5,286,324		Kawai et al.	02-15-1994
		*5,290,457		Karbachasch et al.	03-01-1994
		*5,297,420		Gilliland et al.	03-29-1994
		*5,316,671		Murphy	05-31-1994
		*5,320,760		Freund et al.	6-14-1994
		*5,353,630		Soda et al.	10-11-1994
		*5,358,732		Seifter et al.	10-25-1994
		*5,361,625		Ylvisaker	11-08-1994
		*5,364,527		Zimmerman et al.	11-15-1994
		*5,364,529		Morin et al.	11-15-1994
		*5,374,353		Murphy	12-20-1994
		*5,389,260		Hemp et al	02-14-1995
		*5,393,433		Espenan et al.	02-28-1995
		*5,396,019		Sartori et al.	03-07-1995
		*5,401,401		Hickok et al.	03-28-1995
		*5,401,405		Loker	03-28-1995

FORM PTO-1449-A and B (Modified)			APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
			APPLICANT: Fufang Zha et al.	
Sheet	6	of	17	GROUP ART UNIT: 1797 EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
		*5,403,479		Smith et al.	04-04-1995
		*5,405,528		Selbie et al.	04-11-1995
		*5,411,663		Johnson	05-02-1995
		*5,417,101		Weich	05-23-1995
		*5,419,816		Sampson et al.	05-30-1995
		*5,451,317		Ishida et al.	09-19-1995
		*5,468,397		Barboza et al.	11-21-1995
		*5,470,469		Eckman	11-28-1995
		*5,477,731		Mouton	12-26-1995
		*5,479,590		Lin	12-26-1995
		*5,480,553		Yamamori et al.	01-02-1996
		*5,484,528		Yagi et al.	01-16-1996
		*5,490,939		Gerigk et al.	02-13-1996
		*5,491,023		Tsai, et al.	02-13-1996
		*5,501,798		Al-Samadi et al.	03-26-1996
		*5,525,220		Yagi et al.	06-11-1996
		*5,531,848		Brinda et al.	07-02-1996
		*5,531,900		Raghaven et al.	07-02-1996
		*5,543,002		Brinda et al.	08-06-1996
		*5,552,047		Oshida et al.	09-03-1996
		*5,554,283		Brinda et al.	09-10-1996
		*5,556,591		Jallerat et al.	09-17-1996
		*5,575,963		Soffer et al.	11-19-1996
		*5,597,732		Bryan-Brown	01-28-1997
		*5,607,593		Cote et al.	03-04-1997
		*5,643,455		Kopp et al.	07-01-1997
		*5,647,988		Kawanishi et al.	07-15-1997
		*5,670,053		Collentro et al.	09-23-1997
		*5,677,360		Yamamori et al.	10-14-1997
		*5,688,460		Ruschke	11-18-1997
		*5,733,456		Okey et al.	03-31-1998
		*5,744,037		Fujimura et al.	04-28-1998
		*5,747,605		Breant, et al.	05-05-1998
		*5,766,479		Collentro et al.	06-16-1998
		*5,783,083		Henshaw et al.	07-21-1998
		*5,843,069		Butler et al.	12-30-1998
		*5,846,424		Khudenko	12-08-1998
		*5,888,401		Nguyen	03-30-1999
		*5,895,570		Liang	04-20-1999

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

Sheet 7 of 17

APPLICATION NO.: 10/537,760

ATTY. DOCKET NO.: 2002P87059WOUS

FILING DATE: June 6, 2005

CONFIRMATION NO.: 5173

APPLICANT: Fufang Zha et al.

GROUP ART UNIT: 1797

EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
		*5,906,739		Osterland et al.	05-25-1999
		*5,906,742		Wang et al.	05-25-1999
		*5,914,039		Mahendran et al.	06-22-1999
		*5,918,264		Drummond et al.	06-29-1999
		*5,942,113		Morimura	08-24-1999
		*5,944,997		Pedersen et al.	08-31-1999
		*5,951,878		Astrom	09-14-1999
		*5,958,243		Lawrence et al.	09-28-1999
		*5,968,357		Doelle et al.	10-19-1999
		*5,988,400		Karachevtcev et al.	11-23-1999
		*5,997,745		Tonelli et al.	12-07-1999
		*6,017,451		Kopf	01-25-2000
		*6,024,872		Mahendran	02-15-2000
		*6,036,030		Stone et al.	03-14-2000
		*6,039,872		Wu et al.	03-21-2000
		*6,042,677		Mahendran et al.	03-28-2000
		*6,045,698		Côté et al.	04-04-2000
		*6,045,899		Wang et al.	04-04-2000
		*6,048,454		Jenkins	04-11-2000
		*6,048,455		Janik	04-11-2000
		*6,066,401		Stilburn	05-23-2000
		*6,074,718		Puglia et al.	06-13-2000
		*6,077,435		Beck et al.	06-20-2000
		*6,083,393		Wu et al.	07-04-2000
		*6,096,213		Radovanovic et al.	08-01-2000
		*6,113,782		Leonard	09-05-2000
		*6,120,688		Daly et al.	09-19-2000
		*6,126,819		Heine et al.	10-03-2000
		*6,146,747		Wang et al.	11-14-2000
		*6,149,817		Peterson et al.	11-21-2000
		*6,156,200		Zha et al.	12-05-2000
		*6,159,373		Beck et al.	12-12-2000
		*6,193,890		Pedersen et al.	02-27-2001
		*6,202,475		Selbie et al.	03-20-2001
		*6,214,231		Cote et al.	04-10-2001
		*6,214,232		Baurmeister et al.	04-10-2001
		*6,221,247		Nemser et al.	04-24-2001
		*6,245,239		Cote et al.	06-12-2001
		*6,254,773		Biltoft	07-03-2001

FORM PTO-1449-A and B (Modified)			APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
			APPLICANT: Fufang Zha et al.	
Sheet	8	of	17	GROUP ART UNIT: 1797
				EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
		*6,264,839		Mohr et al.	07-24-2001
		*6,277,512		Hamrock et al.	08-21-2001
		*6,280,626		Miyashita et al.	08-28-2001
		*6,284,135		Ookata	09-4-2001
		*6,290,756		Macheras et al.	09-18-2001
		*6,294,039		Mahendran et al.	09-25-2002
		*6,299,773		Takamura et al.	10-09-2001
		*6,303,026		Lindbo	10-16-2001
		*6,303,035		Cote et al.	10-16-2001
		*6,315,895		Summerton et al.	11-13-2001
		*6,322,703		Taniguchi et al.	11-27-2001
		*6,325,928		Pedersen et al.	12-04-2001
		*6,337,018		Mickols	01-08-2002
		*6,354,444		Mahendran	03-12-2002
		*6,361,695		Husain et al.	03-26-2002
		*6,368,819		Gaddy et al.	04-09-2002
		*6,375,848		Cote et al.	04-23-2002
		*6,387,189		Gröschl et al	05-15-2002
		*6,402,955		Ookata	06-14-2002
		*6,406,629		Husain et al.	06-18-2002
		*6,423,214		Lindbo	07-23-2002
		*6,423,784		Hamrock et al.	07-23-2002
		*6,432,310		Andou et al.	08-13-2002
		*6,440,303		Spiegel	08-27-2002
		*6,444,124		Onyeche et al.	09-03-2002
		*6,468,430		Kimura et al.	10-22-2002
		*6,485,645		Husain et al.	11-26-2002
		*6,495,041		Taniguchi et al.	12-17-2002
		*6,524,481		Zha et al.	02-25-2003
		*6,524,733		Nonobe	02-25-2003
		*6,550,747		Rabie et al.	04-22-2003
		*6,555,005		Zha et al.	04-29-2003
		*6,576,136		De Moel et al.	06-10-2003
		*6,620,319		Behmann et al.	09-16-2003
		*6,627,082		Del Vecchio	09-30-2003
		*6,635,179		Summerton et al.	10-21-2003
		*6,641,733		Zha et al.	11-04-2003
		*6,645,374		Cote et al.	11-11-2003
		*6,656,356		Gungerich et al.	12-02-2003

FORM PTO-1449-A and B (Modified)				APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
				APPLICANT: Fufang Zha et al.	
Sheet	9	of	17	GROUP ART UNIT: 1797	EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
		*6,682,652		Mahendran et al.	01-27-2004
		*6,685,832		Mahendran et al.	02-03-2004
		*6,696,465		Dellaria et al.	02-24-2004
		*6,702,561		Stillig et al.	03-09-2004
		*6,706,189		Rabie et al.	03-16-2004
		*6,708,957		Cote et al.	03-23-2004
		*6,721,529		Chen et al.	04-13-2004
		*6,723,758		Stone, et al.	04-20-2004
		*6,727,305		Pavez Aranguiz	04-27-2004
		*6,743,362		Porteous et al.	06-01-2004
		*6,758,972		Vriens et al	07-06-2004
		*6,770,202		Kidd et al.	08-03-2004
		*6,780,466		Grangeon et al.	08-24-2004
		*6,783,008		Zha et al.	08-31-2004
		*6,790,912		Blong	09-14-2004
		*6,805,806		Arnaud	10-19-2004
		*6,811,696		Wang et al.	11-02-2004
		*6,814,861		Husain et al.	11-09-2004
		*6,821,420		Zha et al.	11-23-2004
		*6,841,070		Zha et al.	01-11-2005
		*6,861,466		Dadalas, et al.	03-02-2005
		*6,863,817		Liu et al.	03-08-2005
		*6,863,823		Côté	03-08-2005
		*6,869,534		McDowell et al.	03-22-2005
		*6,872,305		Johnson et al.	03-29-2005
		*6,881,343		Rabie et al.	04-19-2005
		*6,884,350		Muller	04-26-2005
		*6,884,375		Wang et al.	04-26-2005
		*6,890,435		Ji et al.	05-10-2005
		*6,890,645		Disse et al.	05-10-2005
		*6,893,568		Janson et al.	05-17-2005
		*6,899,812		Cote et al.	05-31-2005
		*6,946,073		Daigger et al.	09-20-2005
		*6,952,258		Ebert et al.	10-04-2005
		*6,955,762		Gallagher et al.	10-18-2005
		*6,962,258		Zha et al.	11-08-2005
		*6,964,741		Mahendran et al.	11-15-2005
		*6,969,465		Zha et al.	11-29-2005
		*6,974,554		Cox et al.	12-13-2005

FORM PTO-1449-A and B (Modified)			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			
Sheet	10	of	17

APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
APPLICANT: Fufang Zha et al.	
GROUP ART UNIT: 1797	EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
		*6,994,867		Hossainy et al.	02-07-2006
		*7,005,100		Lowel	02-28-2006
		*7,018,530		Pollock	03-28-2006
		*7,018,533		Johnson et al.	03-28-2006
		*7,041,728		Zippies, et al.	05-09-2006
		*7,052,610		Janson et al.	05-30-2006
		*7,083,733		Freydina et al.	08-01-2006
		*7,147,778		DiMassimo et al.	12-12-2006
		*7,160,455		Taniguchi et al.	01-09-2007
		*7,160,463		Beck et al.	01-09-2007
		*7,172,701		Gaid et al.	02-06-2007
		*7,223,340		Zha et al.	05-29-2007
		*7,226,541		Muller et al.	06-05-2007
		*7,247,238		Mullette et al.	07-24-2007
		*7,264,716		Johnson et al.	09-04-2007
		*7,300,022		Muller	11-27-2007
		*D462,699		Johnson et al.	09-10-2002
		*D478,913		Johnson et al.	08-26-2003
		*H1,045		Wilson	05-05-1992
		*RE37,549		Mahendran et al.	02-19-2002
		*2002-0070157		Yamada	06-13-2002
		*2002-0148767		Johnson et al.	10-17-2002
		*2003-0038080		Vriens et al.	02-27-2003
		*2003-0057155		Husain et al.	03-27-2003
		*2003-0127388		Ando et al.	07-10-1003
		*2003-0146153		Cote et al.	08-07-2003
		*2003-0150807		Bartels et al.	08-14-2003
		*2003-0178365		Zha et al.	09-25-2003
		*2003-0226797		Phelps	12-11-2003
		*2004-0007525		Rabie et al.	01-15-2004
		*2004-0035770		Edwards et al.	02-26-2004
		*2004-0084369		Zha et al.	05-06-2004
		*2004-0145076		Zha et al.	07-29-2004
		*2004-0168979		Zha et al.	09-02-2004
		*2004-0178154		Zha et al.	09-16-2004
		*2004-0217053		Zha et al.	11-04-2004
		*2004-0232076		Zha et al.	11-25-2004
		*2005-0103722		Freydina et al.	05-19-2005
		*2005-0115880		Pollock	06-02-2005

FORM PTO-1449-A and B (Modified)			APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
			APPLICANT: Fufang Zha et al.	
Sheet	11	of	17	GROUP ART UNIT: 1797 EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
		*2005-0115899		Liu et al.	06-02-2005
		*2005-0194310		Liu et al.	06-02-2005
		*2005-0029185		Muller	02-10-2005
		*2005-0029186		Muller	09-08-2005
		*2005-0032982		Muller et al.	02-10-2005
		*2005-0115899		Liu et al.	06-02-2006
		*2005-0139538		Lazaredes	06-30-2005
		*2005-0194315		Adams et al.	09-08-2005
		*2006-0000775		Zha et al.	01-05-2006
		*2006-0131234		Zha et al.	06-22-2006
		*2006/0201876		Jordan	09-14-2006
		*2006-0261007		Zha et al.	11-23-2006
		*2006-0273038		Syed et al.	12-07-2006
		*2007-0007214		Zha et al.	01-11-2007
		*2007-0056905		Beck et al.	03-15-2007
		*2007-0075021		Johnson	04-05-2007
		*2007-0108125		Cho et al.	05-17-2007
		*2007-0227973		Zha et al.	10-04-2007

FOREIGN PATENT DOCUMENTS

Examiner's Initials	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document (not necessary)	Date of Publication of Cited Document MM-DD-YYYY	Translation (Y-N)
		Office-Country	Number	Kind Code			
		AU	77066/87		Memtec Ltd.	07-11-1986	
		AU	55847/86		Memtec Ltd.	03-05-1985	
		AU	34400/84		Memtec Ltd.	09-30-1983	
		CN	1050770C		Rotem Ind. Ltd.	01-25-1995	Abstract
		DE	29804927	U1	Rochem RO Wasserbehandlung GmbH	06-10-1998	Abstract
		DE	29906389		Cramer Weberei Heek Nienborg GmbH	06-17-1999	Abstract
		DE	3904544	A1	Fraunhofer Ges. Forschung	08-16-1990	Abstract
		DE	4113420	A1	Bayer AG	10-29-1992	Abstract
		DE	4117281	A1	Chemie AG Bitterfeld-Wolfen	01-02-1992	Abstract
		DE	4117422	C1	Dettinger, Willi	11-12-1992	Abstract
		EP	012557	B1	Abcor, Inc.	02-16-1983	
		EP	126714	A2	Christ AG	28-11-1984	Abstract
		EP	050447	B1	Asahi Glass Company Ltd.	10-02-1985	
		EP	090383	B1	HR Textron Inc.	05-23-1990	
		EP	1034835	A1	Biothane Systems International	09-13-2000	
		EP	1236503	B1	Solvay Solexis SpA	08-25-2004	
		EP	1349644		USF Filtration & Separations	10-08-2003	Y

FORM PTO-1449-A and B (Modified)				APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
				APPLICANT: Fufang Zha et al.	
Sheet	12	of	17	GROUP ART UNIT: 1797	EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document (not necessary)	Date of Publication of Cited Document MM-DD-YYYY	Translation (Y-N)
		Office-Country	Number	Kind Code			
		EP	1350555	A1	Toray Industries, Inc.	10-08-2003	
		EP	250337	A1	Rhone-Poulenc Recherches	12-23-1987	Abstract
		EP	327025	A1	Sartorius GMBH	08-09-1989	Abstract
		EP	395133	B1	X-Flow B.V.	02-01-1995	
		EP	407900	A2	Akzo N.V.	01-16-1991	Abstract
		EP	430082	B1	Millipore Corporation	06-19-1996	
		EP	463627	A2	Chemie AG Bitterfeld-Wolfen	01-02-1992	Abstract
		EP	492446	B1	The Dow Chemical Company	11-29-1995	
		EP	492942	A2	Amoco Corporation	07-01-1992	
		EP	518250	B1	Pall Corporation	12-16-1992	
		EP	547575	A1	Permea Inc.	06-23-1993	
		EP	627255	B1	Rotem Industries Ltd.	01-13-1999	
		EP	734758	A1	Mitsui Petrochemical Industries Ltd	10-02-1996	
		EP	763758	A1	Seikoh Giken Co., Ltd.	03-19-1997	
		EP	824956	A2	Essef Corporation	02-25-1998	
		EP	855214	A1	Kanegafuchi Kagaku Kogyo Kabushiki Kaisha	07-29-1998	
		EP	911073	A1	Pall Corporation	04-28-1999	
		EP	920904	A2	Praxair Technology, Inc.	06-09-1999	
		FR	2620712		Pennwalt Corp.	03-24-1989	Abstract
		FR	2674448		Dumez Lyonnaise Eaux	10-02-1992	Abstract
		FR	2699424		Dumez Lyonnaise Eaux	06-24-1994	Abstract
		GB	702911		The British Thomson Houston Co. Ltd.	01-27-1954	
		GB	2253572	A	Aljac Engineering Limited	09-16-1992	
		JP	01-151906		Masayuki Kiuchi	06-14-1989	Abstract
		JP	01-307409		Daicel Chem. Ind. Ltd.	12-12-1989	Abstract
		JP	02-026625		Toshiba Corp.	01-29-1990	Abstract
		JP	02-031200		Ebara Corp.	02-01-1990	Abstract
		JP	02-107318		Daicel Chem. Ind. Ltd.	04-19-1990	Abstract
		JP	02-126922		Mitsui Eng. & Shipbuild. & Co. Ltd.	05-15-1990	Abstract
		JP	02-144132		Mitsubishi Rayon Co.	06-01-1990	Abstract
		JP	02-164423		Toshiba Corp.	06-25-1990	Abstract
		JP	02-277528		Toshiba Corp.	11-14-1990	Abstract
		JP	02-284035		Toyobo Co. Ltd.	11-21-1990	Abstract
		JP	03-018373		Terumo Corp.	01-25-1991	Abstract
		JP	03-028797		Ebara Corp.	02-06-1991	Abstract
		JP	03-110445		Fuji Photo Film Co. Ltd.	05-10-1991	Abstract
		JP	04-187224		Mitsubishi Rayon Co.	07-03-1992	Abstract
		JP	04-250898		Yanmar Diesel Engine Co. Ltd.	09-07-1992	Y-certified
		JP	04-256424		Nitto Denko Corp.	09-11-1992	Abstract

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

FILING DATE: June 6, 2005

CONFIRMATION NO.: 5173

APPLICANT: Fufang Zha et al.

GROUP ART UNIT: 1797

EXAMINER: Menon, Krishnan S.

Sheet 13 of 17

Examiner's Initials	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document (not necessary)	Date of Publication of Cited Document MM-DD-YYYY	Translation (Y-N)
		Office-Country	Number	Kind Code			
	JP	04-265128			Ebara Infilco Co. Ltd.	09-21-1992	Y
	JP	04-293527			Daicel Chem. Ind. Ltd.	10-19-1992	Abstract
	JP	04-310223			Asahi Chem. Ind. Co. Ltd.	11-02-1992	Abstract
	JP	04-348252			House Shokuhin Kogyo KK	12-03-1992	Abstract
	JP	05-137977			Kubota Corp.	06-01-1993	Abstract
	JP	05-023557			Asahi Chem. Ind. Co. Ltd.	02-02-1993	Abstract
	JP	05-096136			Toray Ind. Inc.	04-20-1993	Abstract
	JP	05-157654			Asahi Chem. Ind. Co. Ltd.	06-25-1993	Abstract
	JP	05-285348			Nitto Denko Corp.	11-02-1993	Abstract
	JP	06-071120			Akai Electric Co. Ltd.	03-15-1994	Abstract
	JP	06-114240			Toray Ind. Inc.	04-26-1994	Abstract
	JP	06-218237			Kubota Corp.	08-09-1994	Abstract
	JP	06-277469			Kurita Water Ind. Ltd.	10-04-1994	Abstract
	JP	06-285496			Ebara Infilco Co. Ltd.	10-11-1994	Abstract
	JP	06-343837			Ebara Infilco Co. Ltd.	12-20-1994	Y-certified
	JP	07-024272			Mitsubishi Rayon Co. Ltd.	01-27-1995	Y-certified
	JP	07-068139			Nippon Memtec KK NGK Insulators Ltd.	03-14-1995	Abstract
	JP	07-136470			Mitsubishi Rayon Co. LTD.	05-30-1995	Y
	JP	07-136471			Toray Ind. Inc.	05-30-1995	Abstract
	JP	07-155758			Mitsubishi Rayon Co. Ltd.	06-20-1995	Abstract
	JP	07-178323			NGK Insulators Ltd.	07-18-1995	Abstract
	JP	07-185268			Toray Ind. Inc.	07-25-1995	Y-certified
	JP	07-185271			Kurita Water Ind. Ltd.	07-25-1995	Y
	JP	07-236819			Nok Corp.	09-12-1995	Abstract
	JP	07-251043			Toto Ltd.	10-03-1995	Abstract
	JP	07-275665			Mitsubishi Rayon Co. Ltd.	10-24-1995	Abstract
	JP	07-289860			Toray Ind. Inc.	11-07-1995	Abstract
	JP	07-303895			Kubota Corp.	11-21-1995	Abstract
	JP	08-010585			Ishigaki Mech. Ind. Co.	01-16-1996	Abstract
	JP	09-099227			Kurita Water Ind. Ltd.	04-15-1997	Abstract
	JP	09-141063			Mitsubishi Rayon Co. Ltd.	06-03-1997	Abstract
	JP	09-187628			Nikkiso Co. Ltd.	07-22-1997	Abstract
	JP	09-220569			Kubota Corp.	08-26-1997	Abstract
	JP	09-271641			Kanegafuchi Chem. Ind. Co. Ltd.	10-21-1997	Abstract
	JP	09-324067			Shin Etsu Polymer Co. Ltd.	12-16-1997	Abstract
	JP	10-033955			Hitachi Shipbuilding Eng. Co.	02-10-1998	Abstract
	JP	10-048466			Seiko Instr. Inc.	02-20-1998	Abstract
	JP	10-156149			Nok Corp.	06-16-1998	Abstract
	JP	11-028467			Nippon Kokan KK	02-02-1999	Abstract

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

FILING DATE: June 6, 2005

CONFIRMATION NO.: 5173

APPLICANT: Fufang Zha et al.

Sheet 14

of 17

GROUP ART UNIT: 1797

EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document (not necessary)	Date of Publication of Cited Document MM-DD-YYYY	Translation (Y-N)
		Office-Country	Number	Kind Code			
	JP	11-033365			Asahi Chemical Ind.	09-02-1999	Abstract
	JP	11-156166			Mitsubishi Heavy Ind. Ltd.	06-15-1999	Abstract
	JP	11-165200			Mitsubishi Rayon Co. Ltd.	06-22-1999	Abstract
	JP	11-319507			Toray Ind. Inc.	11-24-1999	Abstract
	JP	11-333265			Nitto Denko Corp.	07-12-1999	Abstract
	JP	2000-157850			Nitto Denko Corp.	06-13-2000	Abstract
	JP	2000-070684			Organo KK	03-07-2000	Abstract
	JP	2000-185220			Asahi Chem. Ind.	04-07-2000	Abstract
	JP	2000-317276			Zenken KK	11-21-2000	Abstract
	JP	2000-342932			Mitsubishi Rayon Co. Ltd.	12-12-2002	Abstract
	JP	2001-079367			Hitachi Plant Eng. & Constr. Co. Ltd.	03-27-2001	Abstract
	JP	2001-009246			Hitachi Plant Eng. & Const. Co	01-16-2001	Abstract
	JP	2001-070967			Asahi Chemical Corp.	03-21-2001	Abstract
	JP	2001-104760			Mitsubishi Heavy Ind. Ltd.	04-17-2001	Abstract
	JP	2001-190937			Sumitomo Heavy Industries	07-17-2001	Abstract
	JP	2001-190938			Miura Kogyo KK	07-17-2001	Abstract
	JP	2001-205055			Daicel Chem.	07-31-2001	Abstract
	JP	2003-047830			Yuasa Battery Co. Ltd.	02-18-2003	Abstract
	JP	2003-062436			Toray Industries	03-04-2003	Abstract
	JP	2003-135935			Mitsubishi Rayon Co.	05-13-2003	Abstract
	JP	54-162684			Ebara Infilco Co. Ltd.	12-24-1979	Abstract
	JP	55-099703			Matsushita Electric Ind. Co. Ltd.	07-30-1980	Abstract
	JP	55-129107			Nitto Electric Ind. Co.	10-06-1980	Abstract
	JP	55-129155			Sakai Chem. Industry Co.	06-10-1980	Abstract
	JP	56-021604			Toray Ind. Inc.	02-28-1981	Abstract
	JP	56-118701			Kuraray Co.	09-17-1981	Abstract
	JP	56-121685			Ebara Infilco Co. Ltd.	09-24-1981	Abstract
	JP	58-088007			Asahi Glass Co. Ltd.	05-26-1983	Abstract
	JP	60-019002			Nippon Atomic Ind. Group Co.	01-31-1985	Abstract
	JP	60-206412			Nitto Electric Ind. Co.	10-18-1985	Abstract
	JP	61-249505			Toyobo Co. Ltd.	11-06-1986	Abstract
	JP	61-097005			Mitsubishi Rayon Co.	05-15-1986	Abstract
	JP	61-097006			Daicel Chem. Ind. Ltd.	05-15-1986	Abstract
	JP	61-107905			Toshiba Corp.	05-26-1986	Abstract
	JP	61-167406			Sumitomo Bakelite Co.	07-29-1986	Abstract
	JP	61-167407			Sumitomo Bakelite Co.	07-29-1986	Y
	JP	61-171504			Agency Ind. Science Techn.	08-02-1986	Abstract
	JP	61-192309			Asahi Chemical Ind.	08-26-1986	Abstract
	JP	61-222510			Nitto Electric Ind. Co.	10-03-1986	Abstract

FORM PTO-1449-A and B (Modified)				APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
				APPLICANT: Fufang Zha et al.	
Sheet	15	of	17	GROUP ART UNIT: 1797	EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document (not necessary)	Date of Publication of Cited Document MM-DD-YYYY	Translation (Y-N)
		Office-Country	Number	Kind Code			
	JP	61-242607			Asahi Chem. Ind. Co. Ltd.	10-28-1986	Abstract
	JP	61-257203			Terumo Corp.	11-14-1986	Abstract
	JP	61-263605			Toshiba Corp.	11-21-1986	Abstract
	JP	61-291007			Toyo Boseki	12-20-1986	Abstract
	JP	61-293504			Kurita Water Ind. Ltd.	12-24-1986	Abstract
	JP	62-004408			Toshiba Corp.	01-10-1987	Abstract
	JP	62-114609			Ebara Corp.	05-26-1987	Abstract
	JP	62-140607			Daicel Chem. Ind. Ltd.	06-24-1987	Abstract
	JP	62-144708			Daicel Chem.	06-27-1987	Abstract
	JP	62-163708			Ebara Corp.	07-20-1987	Abstract
	JP	62-179540			Asahi Chem. Ind. Co. Ltd.	08-06-1987	Abstract
	JP	62-250908			Asahi Chem. Ind. Co. Ltd.	10-31-1987	Abstract
	JP	63-097634			Toray Ind. Inc.	04-28-1988	Abstract
	JP	63-143905			Toshiba Corp.	06-16-1988	Y- certified
	JP	63-171607			Sumitomo Electric Industries	07-15-1988	Abstract
	JP	63-180254			Matsushita Electric Ind. Co. Ltd.	07-25-1988	Abstract
	JP	S63-38884			Asahi Chemical Industry Co. Ltd.	10-13-1988	Y- certified
	KR	2002-0090967			Jinwood Environ. R&D Co. Korea Inst. Sci. Tech.	12-05-2002	Abstract
	NL	1020491C			Norit Membraan Tech. B.V. (NL)	10-28-2003	Abstract
	NL	1021197C			Norit Membraan Tech. B.V. (NL)	10-28-2003	Abstract
	TW	347343			Morimura Kosan KK	12-11-1998	Abstract
	WO	1988-06200			Whitford Plastics Limited	08-25-1988	
	WO	1989-00880			Minntech Corporation	02-09-1989	
	WO	1990-00434			Fairey Arlon Limited	01-25-1990	
	WO	1991-04783			Memtec Limited	04-18-1991	
	WO	1991-16124			Memtec Limited	10-31-1991	
	WO	1993-02779			Memtec Limited	02-18-1993	
	WO	1993-15827			Mitsubishi Rayon Co. Ltd.	08-19-1993	Abstract
	WO	1993-23152			Minntech Corporation	11-25-1993	
	WO	1994-11094			Zenon Environmental Inc.	05-26-1994	
	WO	1995-34424			Mobil Oil Corporation	12-21-1995	
	WO	1996-07470	A1		Memtec Limited	03-14-1996	
	WO	1996-28236			Memtec Limited	09-19-1996	
	WO	1996-41676			United Utilities PLC	12-27-1996	
	WO	1997-06880			Zenon Environmental Inc.	02-27-1997	
	WO	1998-22204			Memtec America Corporation	05-28-1998	
	WO	1998-25694			Memtec America Corporation	06-18-1998	
	WO	1998-53902			USF Filtration and Separations Group Inc.	12-03-1998	
	WO	1999-01207			Zenon Environmental Inc.	01-14-1999	

FORM PTO-1449-A and B (Modified)			APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
			APPLICANT: Fufang Zha et al.	
Sheet	16	of	17	GROUP ART UNIT: 1797 EXAMINER: Menon, Krishnan S.

Examiner's Initials	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document (not necessary)	Date of Publication of Cited Document MM-DD-YYYY	Translation (Y-N)
		Office-Country	Number	Kind Code			
	WO	1999-59707			USF Filtration and Separations Group Inc.	11-25-1999	
	WO	2000-30742			Zenon Environmental Inc.	06-02-2000	
	WO	2001-00307			Millenniumpore Limited	01-04-2001	
	WO	2001-32299			Stork Friesland B.V.	05-10-2001	
	WO	2001-36075			Zenon Environmental Inc.	05-25-2001	
	WO	2001-45829	A1		Zenon Environmental Inc.	06-28-2001	
	WO	2002-40140	A1		Aquasource	05-23-2002	Abstract
	WO	2003-000389	A2		Petro Sep International Ltd.	01-03-2003	
	WO	2003-013706	A1		U.S. Filter Wastewater Group, Inc.	02-20-2003	
	WO	2004-101120	A1		Soo-Hong Noh	11-25-2004	
	WO	2005-021140	A1		U.S. Filter Wastewater Group, Inc.	03-10-2005	
	WO	2005-037414	A1		Krishnamurthi Rao, C.H.	04-28-2005	
	WO	2005-077499	A1		U.S. Filter Wastewater Group, Inc.	08-25-2005	
	WO	2006-029456	A1		U.S. Filter Wastewater Group, Inc.	03-23-2006	

OTHER ART — NON PATENT LITERATURE DOCUMENTS

Examiner's Initials	Cite No	Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue number(s), publisher, city and-or country where published.	Translation (Y-N)
		ALMULLA et al., Desalination, 153 (2002), pp. 237-243.	
		Anonymous, "Nonwoven Constructions of Dyneon™ THV and Dyneon™ THE Fluorothermoplastics", Research Disclosure Journal, April 1999, RD 420013, 2 pages	
		COTE et al., Wat. Sci. Tech. 38(4-5) (1998), pp. 437-442.	
		Cote, et al. "A New Immersed Membrane for Pretreatment to Reverse Osmosis" Desalination 139 (2001) 229-236.	
		CRAWFORD et al., "Procurement of Membrane Equipment: Differences Between Water Treatment and Membrane Bioreactor (MBR) Applications" (2003).	
		DAVIS et al., Membrane Technology Conference, "Membrane Bioreactor Evaluation for Water Reuse in Seattle, Washington" (2003).	
		DeCAROLIS et al., Membrane Technology Conference, "Optimization of Various MBR Systems for Water Reclamation" (2003).	
		Dow Chemicals Company, "Filmtec Membranes – Cleaning Procedures for Filmtec FT30 Elements," Tech Facts, Online, June 30, 2000, XP002237568.	
		HUSAIN, H. et al., "The ZENON experience with membrane bioreactors for municipal wastewater treatment," MBR2: Membr. Bioreact. Wastewater Treat., 2 nd Intl. Meeting; School of Water Sciences, Cranfield University, Cranfield, UK, June 1999.	
		JOHNSON, "Recent Advances in Microfiltration for Drinking Water Treatment," AWWA Annual Conference, June 20-24, 1999, Chicago, Illinois, entire publication	
		Recent Advances in Microfiltration for Drinking Water Treatment; An Introduction to CMF-S, Presentation.	
		KAIYA et al., "Water Purification Using Hollow Fiber Microfiltration Membranes," 6th World Filtration Congress, Nagoya, 1993, pp. 813-816.	

FORM PTO-1449-A and B (Modified)				APPLICATION NO.: 10/537,760	ATTY. DOCKET NO.: 2002P87059WOUS
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				FILING DATE: June 6, 2005	CONFIRMATION NO.: 5173
				APPLICANT: Fufang Zha et al.	
Sheet	17	of	17	GROUP ART UNIT: 1797	EXAMINER: Menon, Krishnan S.

		LLOYD D.R. et al. "Microporous Membrane Formation Via Thermally Induced Phase Separation-Solid-Liquid Phase Separation" <i>Journal of Membrane Science</i> , (09-15-1990), pages 239-261, Vol. 52, No. 3, Elsevier Scientific Publishing Company, Amsterdam, NL.		
		LOZIER et al., "Demonstration Testing of ZenoGem and Reverse Osmosis for Indirect Potable Reuse Final Technical Report," published by CH2M Hill, available from the National Technical Information Service, Operations Division, January 2000, entire publication		
		MicroC™ -Carbon Source for Wastewater Denitrification. Information from Environmental Operating Solutions website including MSDS.		
		NAKAYAMA, "Introduction to Fluid Mechanics," Butterworth-Heinemann, Oxford, UK, 2000.		
		RAMASWAMMY S. et al. "Fabrication of Ply (ECTFE) Membranes via thermally induced phase Separation", <i>Journal of Membrane Science</i> , (12-01-2002), pages 175-180, Vol. 210 No. 1, Scientific Publishing Company, Amsterdam, NL.		
		ROSENBERGER et al., Desalination, 151 (2002), pp. 195-200.		
		UEDA et al., "Effects of Aeration on Suction Pressure in a Submerged Membrane Bioreactor," Wat. Res. Vol. 31, No. 3, 1997, pp. 489-494.		
		<i>Water Encyclopedia</i> , edited by Jay Lehr, published by John Wiley & Sons, Inc., Hoboken, New Jersey, 2005. Available at http://wwwmmrw.interscience.wiley.com/eow/ .		
		WHITE et al., <i>The Chemical Engineering Journal</i> , 52 (1993), pp. 73-77.		
		Wikipedia, "Seawater," available at http://en.wikipedia.org/wiki/Seawater , July 15, 2007.		
		ZENON, "Proposal for ZeeWeed® Membrane Filtration Equipment System for the City of Westminster, Colorado, Proposal Number 479-99," March 2000, entire publication		

EXAMINER	DATE CONSIDERED
----------	-----------------

#EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

*a copy of this reference is not provided either because it was previously cited by or submitted to the office in a prior application, Serial No. ____, filed ____, and relied upon for an earlier filing date under 35 U.S.C. 120 (continuation, continuation-in-part, and divisional applications) or because a copy of this reference need not be provided as the reference is a published U.S. Patent or U.S. Patent application and the present application was filed after June 30, 2003.